

Notice of References Cited	Application/Control No. 09/751,877	Applicant(s)/Patent Under Reexamination YEN ET AL.	
	Examiner Cybille Delacroix-Muirheid	Art Unit 1614	Page 1 of 1


U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2004/0023860	02-2004	Yen et al.	514/12
	B	US-			
	C	US-			
	D	US-			
	E	US-			
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FOREIGN PATENT DOCUMENTS

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